Electronic Acknowledgement Receipt					
EFS ID:	1006605				
Application Number:	10711649				
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Title of Invention:	A METHOD FOR SUPERCRITICAL CARBON DIOXIDE PROCESSING OF FLUORO-CARBON FILMS				
First Named Inventor:	Kohei Kawamura				
Customer Number:	37694				
Filer:	Kristi Lynn Davidson/Debbie Goodman				
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Application Type:	Utility				

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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Information Disclosure Statement (IDS) Filed	US_IDS_FormSB_08a.pdf	4235949	no	6
Warnings:					

2	Information Disclosure Statement (IDS) Filed	WO03064065A1.pdf	2272210	no	27	
Warnings:						
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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.